

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Kobayashi, Kobayashi

Serial No.: 10/060,569

Group Art Unit: 1763

Filed: January 29, 2002

Examiner: Goudreau, George A.

Title: METHOD OF FABRICATING A SEMICONDUCTOR DEVICE

F#47
10/23/02
MW

Attorney Docket No.: N230500C1

REQUEST FOR INTERVIEW

5 Assistant Commissioner for Patents
Washington, D.C. 20231

Dear Sir:

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Applicants respectfully request a phone interview to discuss various matters related to the present application.

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37 C.F.R. §1.8

I hereby certify that this correspondence is being

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transmitted via facsimile to the United States Patent and Trademark Office to fax number: 1-703-872-9310
Date of Transmittal: October 21, 2002

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[] deposited with the United States Postal Service as first class mail in an envelope addressed to: Assistant Commissioner for Patents, Washington, D.C. 20231.

Date of Deposit: _____

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Typed/Printed Name: Bradley T. SakoSignature: Kobayashi

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICEIssues for Interview

We would like to discuss the following issues:

1) The patentability newly submitted claims 41-48 (filed 10/15/02 via fax).

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2) The basis for modifying the reference *Barth et al.* ("Advanced PVD Ti/TiN Liners for Contact and Via Applications, SPIE, Vol. 3214 (1997)) in order to show the limitation

10 "etching back a conductive layer to form a plug that has a top surface which projects above a top surface of an insulating layer"

3) The patentability of claim 35, in light of the reference teachings.

Contact for Interview

15 We would greatly appreciate it if the following attorney of record could be contacted to arrange for the interview.

Brad Sako

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Respectfully Submitted,

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